

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments
1	BRS	L3	1191	lens SAME (thickness near3 (adjust\$3 change\$3))	USPA T; US-P GPUB ; EPO; JPO; DERW ENT; IBM TDB	2003/02/0 6 14:25	
2	BRS	L7	9	L4 AND vapor AND etch\$3	USPA T; US-P GPUB ; EPO; JPO; DERW ENT; IBM TDB	2003/02/0 6 14:27	
3	BRS	L5	6	L2 AND vapor AND etch\$3	USPA T; US-P GPUB ; EPO; JPO; DERW ENT; IBM TDB	2003/02/0 6 14:28	
4	BRS	L6	65	L3 AND vapor AND etch\$3	USPA T; US-P GPUB ; EPO; JPO; DERW ENT; IBM TDB	2003/02/0 6 14:29	

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments
5	BRS	L4	22	L1 AND vapor	USPA T; US-P GPUB ; EPO; JPO; DERW ENT; IBM- TDB	2003/02/06 14:32	
6	BRS	L1	121	lens SAME (thickness near3 (adjust\$3 change\$3)) SAME (manufacture\$3 fabricat\$3 error\$1)	USPA T; US-P GPUB ; EPO; JPO; DERW ENT; IBM- TDB	2003/02/06 14:33	
7	BRS	L2	158	lens SAME (thickness near3 (adjust\$3 change\$3)) SAME (manufacture\$3 tolerance\$3 dimension\$3 error\$1)	USPA T; US-P GPUB ; EPO; JPO; DERW ENT; IBM- TDB	2003/02/06 14:35	

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments
1	BRS	L1	2778	427/162,166,255.2,255.5.ccls.	USPA T; US-P GPUB ; EPO; JPO; DERW ENT; IBM_ TDB	2003/02/06 14:39	
2	BRS	L2	0	1 and ((adjust\$3) near4 (optical adj thickn\$3))	USPA T; US-P GPUB ; EPO; JPO; DERW ENT; IBM_ TDB	2003/02/06 14:40	
3	BRS	L3	770	1 and (vapor adj deposition)	USPA T; US-P GPUB ; EPO; JPO; DERW ENT; IBM_ TDB	2003/02/06 14:41	
4	BRS	L4	17	3 and (optical adj component)	USPA T; US-P GPUB ; EPO; JPO; DERW ENT; IBM_ TDB	2003/02/06 14:41	

	Type	L #	Hits	Search Text	DBs	Time Stamp
1	BRS	L1	1337	359/642,742,743.ccls.	USPA T; US-P GPUB ; EPO; JPO; DERW ENT; IBM TDB	2003/02/06 14:44
2	BRS	L2	38	1 and (optical adj component)	USPA T; US-P GPUB ; EPO; JPO; DERW ENT; IBM TDB	2003/02/06 14:44
3	BRS	L3	36	2 and light	USPA T; US-P GPUB ; EPO; JPO; DERW ENT; IBM TDB	2003/02/06 14:44
4	BRS	L4	3	3 and ((vapor adj deposition)or (vapor adj groth))	USPA T; US-P GPUB ; EPO; JPO; DERW ENT; IBM TDB	2003/02/06 14:46